



RHM-US020574

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Patent Art Unit: 3742
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Toshikuni Shinohara	:	Examiner: Tu Ba Hoang
	:	
Serial No.: 10/707,989	:	
	:	
Filed: Jan. 30, 2004	:	
	:	
For: Plasma Processing Apparatus	:	

INFORMATION DISCLOSURE STATEMENT WITH CERTIFICATION

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant brings the following references to the Examiner's attention and requests that they be considered and made of record in this application. Also attached is a completed PTO-1449 form.

1. US patent application publication 2002/0079294 to Tadera et al., published June 27, 2002 (corresponding to US Patent No. 6,753,496).
2. US patent application publication 2002/0123200 to Yamamoto et al., published Sept. 5, 2002 (corresponding to US Patent No. 6,783,628).
3. US Patent No. 6,325,018 to Hongoh, published Dec. 4, 2001
4. US patent application publication 2001/0050058 to Yamamoto et al., published Dec. 13, 2001 (corresponding to US Patent No. 6,620,290).
5. Japanese unexamined patent application publication H11-26190A (together with English language machine translation of same provided by the Japan Patent Office), published January 29, 1999.
6. Japanese unexamined patent application publication H11-067492A (together with English language machine translation of same provided by the Japan Patent Office), published March 9, 1999 .

7. Japanese unexamined patent application publication H10-275696A (together with English language machine translation of same provided by the Japan Patent Office), published October 13, 1998 .

8. Japanese unexamined patent application publication H10-255998A (together with English language machine translation of same provided by the Japan Patent Office), published Sept. 25, 1998.

9. US Patent No. 5,698,036 to Ishii et al., published Dec. 16, 1997.

10. Japanese unexamined patent application publication H08-241797A (together with English language machine translation of same provided by the Japan Patent Office), published Sept. 17, 1996.

11. Japanese unexamined patent application publication H08-274083A (together with English language machine translation of same provided by the Japan Patent Office), published October 18, 1996.

12. Japanese unexamined patent application publication H05-129095A (together with English language machine translation of same provided by the Japan Patent Office), published May 25, 1993.

I hereby certify that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

No fee is believed to be required in view of the above certification. However, Applicant authorizes the Commissioner of Patents to charge payment of the petition fee under 37 CFR § 1.17(p) *if required* and any other fees associated with this communication or credit any overpayment to Deposit Account No. 19-2042.

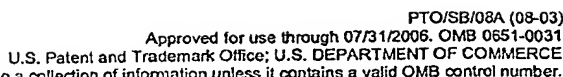
Respectfully submitted,



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Dated: March 18, 2005

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Substitute for form 1449/PTO

(Use as many sheets as necessary)

Complete if Known

Application Number	10/707,989
Filing Date	Jan. 30, 2004
First Named Inventor	Shinohara
Art Unit	3742
Examiner Name	Tu Ba Hoang
Attorney Docket Number	RHM-US020574

Sheet	2	of	2
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U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ²
		Country Code ³ *Number ⁴ *Kind Code ⁵ (if known)				
		JP H05-129095A	05-25-1993	Hitachi Ltd.		

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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